INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 8, 2026

IGI Report Number	LG846634142
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	8.53 X 5.91 X 4.10 MM

GRADING RESULTS

Carat Weight	2.08 CARATS
Color Grade	E
Clarity Grade	VS 2

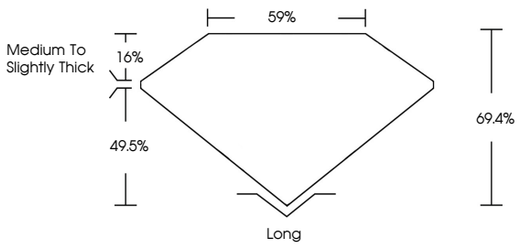
ADDITIONAL GRADING INFORMATION

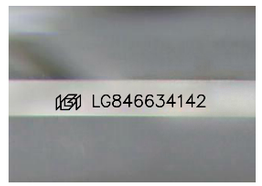
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG846634142

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG846634142
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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GRADING RESULTS
Carat Weight 2.08 CARATS
Color Grade E
Clarity Grade VS 2

Medium To Slightly Thick
16%
49.5%
59%
69.4%
Long

ADDITIONAL GRADING INFORMATION
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
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IGI

October 8, 2026
IGI Report No LG846634142
EMERALD CUT
8.53 X 5.91 X 4.10 MM
Carat Weight 2.08 CARATS
Color Grade E
Clarity Grade VS 2
Depth 69.4%
Table 59%
Girdle Medium To Slightly Thick
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG846634142
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa